

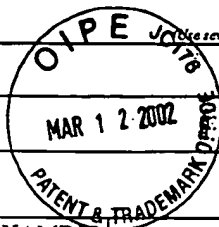
INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Docket Number (Optional)

AKM-00601

Application No.

10/074,756



(Use several sheets if necessary)

Applicant

Fumihiko FUJISHIRO, et al.

Filing Date

February 12, 2002

Group Art Unit

Au 2673
To be determined**U.S. PATENT DOCUMENTS**

EXAMINER R INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA					
	AB					
	AC					
	AD					
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FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
22	AF 2000-500277	1/11/2000	JP			
29	AG 2000-500916	1/25/2000	JP			
33	AH 2000-503801	3/28/2000	JP			
33	AI 2000-500917	1/25/2000	JP			
	AJ					
	AK					

OTHER DOCUMENTS (Including author, Title, Date, Pertinent Pages, Etc.)

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EXAMINER

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Applicant **FUJISHIRO, et al.**Filing Date **February 12, 2002**Group Art Unit **2673****U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AA	6,060,828	05/09/2000	Frank Vollkommer, et al.			
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RECEIVED**FEB 13 2004****Technology Center 2600****FOREIGN PATENT DOCUMENTS**

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
AL	2000-90884	03/31/2000	JP				X
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AN							
AO							
AP							
AQ							

OTHER DOCUMENTS

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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation
AF	2000-90884	3-31-00	JP			
AG	10-222083	8-21-98	JP			
AH	2002-93379	3-29-02	JP			
AI	2000-500277	1-11-00	JP			
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OTHER DOCUMENTS (Including author, Title, Date, Pertinent Pages, Etc.)

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